

Electronic Patent Application Fee Transmittal

Application Number:	10552984			
Filing Date:	25-Sep-2006			
Title of Invention:	TEST STRUCTURE FOR ELECTRICALLY VERIFYING THE DEPTHS OF TRENCH-ETCHING IN AN SOI WAFER, AND ASSOCIATED WORKING METHODS			
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Attorney Docket Number:	P28504			
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
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Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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